



IONIZED JET DEPOSITION

NOVEL THIN FILM COATING TECHNOLOGY

HIGH DEPOSITION RATES

STOICHIOMETRY CONSERVATION

LAB SCALE / R&D / INDUSTRIAL

INDEPENDENT PROCESS
TUNING PARAMETERS

LOW TEMPERATURE PROCESS

WIDE RANGE OF MATERIALS

HIGH QUALITY COATINGS

COMPETITIVE COST



www.noivion.com

NOIVION Coating s.r.o., Czech Republic & NOIVION Srl. Italy

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LAB JET40 - SMALL R&D DEPOSITION SYSTEM

Multi-purpose configuration:

- └ 125 l Chamber
- └ 1 IJD source
- └ Optional addons:
 - magnetron
 - laser window
 - thermal evaporation
 - electron beam ev.
 - heated sample holder
 - carousel
 - etc.



MEDIUM SIZE R&D DEPOSITION SYSTEMS



LAB JET 6.0

240 l Chamber



LAB JET 8.0

460 l Chamber

└ Up to 5 IJD heads + optional addons: magnetron sputtering, laser window, thermal evaporation, electron beam evaporation, heated sample holder, carousel, etc.



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